

Docket No. 200690US2CONT

V. Douglas
#3/PuA
2/6/01

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
Juen-Kuen LIN, et al. : EXAMINER:
SERIAL NO: New Application :
FILED: Herewith : GROUP ART UNIT:
FOR: WAFER POLISHING HEAD

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to an examination on the merits, please amend the above-identified patent application as follows:

IN THE SPECIFICATION

Page 4, line 5, change "controlled" to --controller--.

Page 6, line 16, change "wafer 60" to --wafer 66--.

IN THE CLAIMS

Please cancel Claims 2, 3 and 8-10 without prejudice.